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SEP 28 2004

In re Application of Toru Hosoi
Application No.: 09/892,500
Filed: June 28, 2001
Attorney Docket No. PNDF-01095

WITHDRAWAL FROM ISSUE
37 CFR 1.313

This is a decision on the petition filed September 9, 2004, requesting that the above-identified application be withdrawn from issue for consideration of the Request for Continued Examination and the Information Disclosure Statement filed herewith. See 37 C.F.R. § 1.313.

The petition to withdraw from issue is GRANTED.

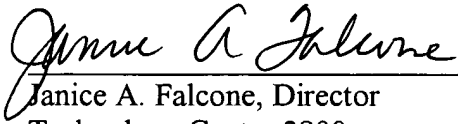
A Notice of Allowance was mailed July 28, 2004. The issue fee has not been paid.

The Request for Continued Examination and the Information Disclosure Statement filed herewith complies with 37 C.F.R. § 1.114.

If the issue fee has been submitted, the applicant may request a refund, or may request that the fee be credited to a deposit account. However, applicant may wait until the application is either again found allowable or held abandoned. If the application is allowed, upon receipt of a new Notice of Allowance and Fee(s) Due, applicant may request that the previously submitted issue fee be applied toward payment of the issue fee in the amount identified on the new Notice of Allowance and Fee(s) Due. If the application is abandoned, applicant may request either a refund or a credit to a Deposit Account.

Any question regarding this communication should be directed to Edward Glick, Supervisory Patent Examiner, at (571) 272-2490.

The examiner will notify applicant of the new status of this application in an Office action to be issued promptly.

A handwritten signature in cursive script, reading "Janice A. Falcone", written in black ink. The signature is positioned above a horizontal line.

Janice A. Falcone, Director
Technology Center 2800
Semiconductors, Electrical and Optical
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